

Electronic Acknowledgement Receipt

EFS ID:	1118629
Application Number:	10074884
Confirmation Number:	6510
Title of Invention:	Semiconductor topography including a thin oxide-nitride stack and method for making the same
First Named Inventor:	Krishnaswamy Ramkumar
Customer Number:	35617
Filer:	Kevin L. Daffer/Pamela Gerik
Filer Authorized By:	Kevin L. Daffer
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		RFOA_5-19-06.pdf	125857	yes	7

	Multipart Description		
	Doc Desc	Start	End
	Amendment After Final	1	1
	Claims	2	5
	Applicant Arguments/Remarks Made in an Amendment	6	7
Warnings:			
Information:			
Total Files Size (in bytes):		125857	
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